Unimolecular decomposition of antimony and bismuth cluster ions studied by surface collision induced dissociation mass spectrometry

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Received 8th November 2001, Accepted 4th January 2002 First published as an Advance Article on the web 26th February 2002

Fragment ion distributions of antimony clusters Sb_n^+ (n=3–12) and bismuth clusters Bi_n^+ (n=3–8) after collision with different solid target surfaces at hyperthermal energies are reported. The measured fragmentation patterns for antimony and bismuth clusters of the same size are similar. Main fragmentation channels identified in our study at impact energies up to 150 eV correspond to the sequential unimolecular dissociation of the colliding clusters with a preferred loss of stable neutral tetrameric and dimeric cluster units. The efficiency of the energy transfer from kinetic energy into internal cluster energy during surface collision was found to be up to 10%. The fragmentation patterns are independent of the employed target surface. In contrast, the integral scattered ion yield strongly depends on the surface type. High scattered ion yields are observed for a silicon oxide surface with high work function, whereas graphite or metallic gold target surfaces result in considerably lower scattered ion yields. For a given surface the integral ion yield also shows strong variations as function of the size of the colliding clusters.

I. Introduction

Within the last two decades, it has been possible to generate free microscopic clusters of metallic elements with a discrete number of constituents. Clusters consisting of a few up to several hundred atoms have become thus amenable to detailed experimental investigations under well defined conditions.¹ Amid the metallic elements, antimony and bismuth have been among the first of which clusters over a broad size range could be generated.² One central subject of interest in metal clusters has been the electronic structure as a function of cluster size. A great deal of insight into the transition to bulk metal properties has been obtained from photoionization mass spectrometry and photoelectron spectroscopy.¹ Electron impact ionization studies indicate that small clusters of antimony and bismuth are essentially non-metallic. The measured ionization potentials of bismuth clusters, however, are found to be closer to the metallic droplet value than those of antimony.^{3–5}

A further very important and hitherto for most metallic elements widely open subject is the geometric structure of metal clusters with a defined mass, because fundamental structural changes are expected to occur with varying the cluster size. In this respect, clusters of the semi-metals antimony and bismuth are particularly interesting since the bulk materials already exist in several metallic, as well as non-metallic, structural modifications. Furthermore, these elements show a strong tendency to form homopolyatomic cluster ions in the condensed phase like, e.g., Sb₃⁷⁻ in some Zintl phases, or Bi₅³⁺, Bi₈²⁺, and Bi₉⁵⁺ which are well characterized stable Zintl cations. T,8

Early structural assignments to neutral gas phase antimony clusters rely on the striking intensity patterns observed in mass spectrometric experiments, which suggest that Sb₄ is the main building unit of these particles.^{2,9} This interpretation has been verified by *ab initio* molecular dynamic studies, too.^{10,11}

In the investigation presented here, we address the problem of structure and stability by applying the method of surface collision induced dissociation (SID) to free clusters of antimony and bismuth. First results have been published in two preceding publications. ^{12,13} Furthermore, the collision induced processes taking place at collision energies exceeding 150 eV are subject of two recent papers. 14,15 Here we will focus on the low energy collision regime (<150 eV). Comparison of our results to previously obtained data from other gas phase dissociative probes such as photodissociation (PD) or dissociation by collision with gaseous targets (CID) reveals that the reaction mechanism for the observed surface induced dissociation is the sequential cluster decomposition via the lowest energy unimolecular dissociation steps. Based on this mechanism, conversion efficiencies of cluster kinetic to internal energy are deduced for selected clusters. Furthermore, the influence of the target surface material on dissociation mechanism, energy transfer and scattering efficiency is investigated. The results elucidate charge and energy transfer processes upon clustersurface contact, the knowledge of which represents an elementary prerequisite for the design of controlled cluster deposition experiments which may lead to the synthesis of new nano-structured materials. 16,17

II. Experimental

The experiments were performed in a newly developed molecular beam apparatus, which has been especially designed to investigate the interaction of metal clusters with solid surfaces. An intense pulsed discharge cluster ion source was combined with a time-of-flight mass spectrometer arrangement with a special compact geometry, enabling high transmission at reasonable resolution. The setup has been described in brief previously ^{12,13,18} and will be detailed below.

The molecular beam apparatus is schematically depicted in Fig. 1 and consists of three conflat-sealed, differentially pumped chambers. The cluster ion source is mounted in the

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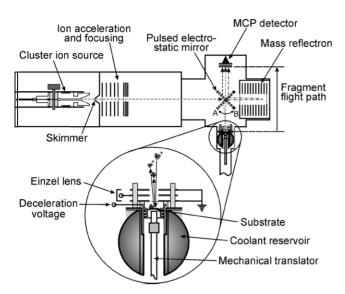


Fig. 1 The molecular beam apparatus employed for the cluster synthesis and SID experiments in a schematic representation. The dashed line indicates the cluster ion trajectories in the time-of-flight mass spectrometer up to the electrostatic ion mirror (in position A) and the deflection directly onto the detector (low resolution mode, see text). Higher mass resolution can be obtained by using the mass reflectron. The ion trajectories behind the electrostatic mirror (rotated to position B) are indicated by the dashed—dotted line for this particular case. For the surface scattering experiment, the ions are deflected by the mirror (in position B) toward the target substrate and fragment ions are analyzed by their flight time from the surface to the detector (dotted line). The insert shows an enlarged view of the surface scattering assembly. The attached surface preparation UHV chamber is not shown here.

first chamber, which is pumped by two turbomolecular pumps with $1000\,1\,\mathrm{s}^{-1}$ capacity each. The second chamber with the ion acceleration electrodes is evacuated by another $1000\,1\,\mathrm{s}^{-1}$ turbomolecular pump and the third, surface scattering arrangement and detector chamber is pumped by a 600 1 s⁻¹ turbomolecular pump. Base pressure in all chambers is 1 × 10^{-10} mbar, the pressure during operation of the source never exceeds 1×10^{-7} mbar in the surface region and is solely due to the seed gas used for cluster production (He, 99.9999% purity). Further ultra high vacuum (UHV) chambers, which are not shown here, are attached to the surface scattering arrangement for convenient surface preparation and analysis. ¹⁸

Particularly important for the present experiment is the electrostatic ion mirror in the third chamber. By rotating this mirror and by switching the electric field, the molecular ion beam can be deflected in either of three directions and the arrangement operates accordingly as: (i) simple time-of-flight mass spectrometer; (ii) as high resolution reflectron mass spectrometer; or (iii) as mass-selected, surface scattering and fragment ion detection spectrometer

A. Cluster ion source

Cluster ions were directly generated by a gas discharge ion source, which is shown schematically in Fig. 2. Helium gas with a backing pressure of up to 20 bar is pulsed between two electrodes by a commercial solenoid valve (General valve Ser. 9). Correlated with the He gas pulse, a high voltage pulse (up to 1 kV) is applied to the electrodes and thus a discharge lasting several tens of microseconds is generated. In the course of the discharge electrode material is evaporated or sputtered from the cathode. A plasma is generated consisting of rare gas ions, electrons and metal ions. This plasma flows through the nozzle channel (length: up to 80 mm, diameter 1 to 3 mm) to enhance cluster formation and is finally expanded into the vacuum. The energy for the gas discharge is delivered by high

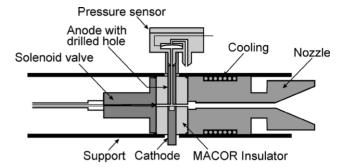


Fig. 2 Schematic drawing of the pulsed discharge cluster ion source. The cylindrical molybdenum electrodes (5 mm diameter) are mounted in a $40 \times 40 \times 20$ mm MACOR insulator block which has a center channel with rectangular cross section of 5×1 mm. For adjustment of the appropriate timing between valve opening and discharge ignition the gas pressure inside the MACOR block can be monitored *via* a miniature pressure sensor (Sensortechnics, Puchheim, Germany) attached to the bored anode.

voltage capacitors with capacities between 10 and 40 μ F. For optimal timing control between discharge and gas pulse, the gas pressure inside the source is monitored with a miniature semiconductor pressure sensor, ¹⁹ which is directly connected to the inside of the source, *i.e.* the discharge region, by a hole drilled into the anode (Fig. 2). We used high purity (99.9999%) helium carrier gas in order to avoid the presence of trace amounts of oxygen and water, since these lead instantly to the formation of oxides and hydroxides. ²⁰ The antimony and bismuth samples were of 99.999% purity (Alfa/Johnson Matthey). These materials were mechanically pressed into a hole in the molybdenum cathode (molybdenum > 99.9% purity, Alfa/Johnson Matthey).

B. Time-of-flight mass spectrometer

The mass spectrometer is aligned with the molecular beam emerging from the discharge source. After passing the skimmer, the ions are accelerated by a two stage Wiley/McLaren type field.²¹ The beam can be focused by a single einzel lens in the field free drift path. The third chamber contains the specially designed ion mirror. It consists of two stainless steel meshes with 90% transmission. One mesh is always on ground potential and a high voltage pulse is applied to the second one. The ion mirror is set up in such a way that it can be rotated by 360 degree during the experiment. If the mirror is in position A (Fig. 1) and on high constant potential, the ions are directly deflected onto a chevron dual multichannel plate (MCP) detector. In this mode the mass resolution is $m/\Delta m = 85$. Massselection is achieved by the application of a high voltage pulse, which is timed to allow only the ion packet with the mass-tocharge ratio of interest to pass the mirror in the direction of the detector.

In order to obtain a higher mass resolution a double field reflectron has been added to the apparatus. ^{22,23} In the reflectron mode (Position B, Fig. 1), the accelerated ions first pass the grounded mirror and are subsequently reflected. The reflected ions arrive again at the mirror, which has been switched to a high potential in the meantime, and are deflected toward the detector. The mass resolution achieved in this reflectron mode is $m/\Delta m = 400$.

If the mirror is rotated by 90° to position B, the cluster ions are directed onto the substrate surface, which is located directly opposite the detector and SID spectra can be recorded.

C. Surface scattering experiment

In most of the experiments presented here highly oriented pyrolytic graphite (HOPG) was employed as substrate material. The graphite (0001) basal plane is a well defined, inert, and easy

to prepare surface. The samples were cleaved in air prior to their installation into the vacuum chamber. In this way an atomically flat (0001) surface can be obtained. Further cleaning is achieved by heating the substrate to 600°C in UHV for several hours.

The cluster ions were also scattered from a Si(001) surface. This surface is used with the naturally present thin surface oxide layer, which reduces the reactivity of the uncovered silicon surface and also increases the surface electron binding energy, thus reducing neutralization probability of the colliding cluster ions. Scattering from this surface therefore leads to an increased scattered ion yield as will be shown below. We employed a boron p-doped silicon wafer disk, which was cleaned by heating to 600 °C in UHV.

The third substrate, which was used for the SID of selected antimony cluster ions, was a metallic gold sample. A well defined Au(111) surface with atomically flat areas of the size of over 1000 nm² was prepared by deposition of a ca. 200 nm thick gold film onto a 150 µm thick Mica sheet.²⁵ These samples were cleaned immediately before their insertion into the vacuum chamber by flame-annealing, i.e. heating to a red glow with a butane flame for about one second. Further cleaning was achieved by heating in vacuum to 400 °C, in order to remove water traces.

Following preparation, the substrate is transferred to the scattering assembly inside the vacuum chamber without breaking vacuum by rotation/translation feedthroughs. The substrate surface is positioned directly opposite the ion detector, at the same distance from the electrostatic mirror as the detector (Fig. 1). If the mirror is rotated to position B, the ions are focused onto the substrate surface. Ions and fragment ions, which are reflected or scattered from the surface, are then accelerated along the surface normal toward the detector. After passage of the mirror, which has been switched to ground potential in the meantime, they reach the MCPs and are detected with flight times according to their mass-to-charge

The insert of Fig. 1 shows an enlarged view of the surface scattering setup. The substrate holder is pushed against a copper electrode inside the scattering assembly. The copper electrode is mounted inside a liquid nitrogen cryostat to allow the variation of surface temperature. The experiments presented here were all carried out at room temperature. The incident cluster ions are decelerated in front of the surface by the high bias voltage applied to the substrate. In addition, an einzel lens arrangement is mounted in front of the deceleration field to focus the cluster beam onto the surface. A surface collision takes place, if the surface potential is lower than the maximum beam energy given by the acceleration voltage.

The energy width of the cluster ion beam can be reduced efficiently in our setup by an appropriate delayed pulsing of the acceleration fields of the mass spectrometer.²⁶ The energy width in the experiments presented here was chosen to be between ± 20 and ± 50 eV, according to the intensity requirements for the incident cluster ion beam.

Results and discussion

A. Structure and stability of antimony and bismuth clusters

In this section we will first briefly review known data about the structure and energetics of antimony and bismuth clusters which are essential to the understanding of the measured mass spectra and stability patterns. The gas phase of antimony consists over a broad temperature range exclusively of the tetramer Sb₄. 27 This cluster has a tetrahedral structure 28-30 and a relatively high total binding energy of 8.9 eV.³¹ The energy necessary for the dissociation of Sb_4 in two Sb_2 molecules has been reported to be 2.86 eV³¹ or 2.5 eV.³² The binding energy of Sb₂ has been measured to be 3.1 eV.³¹ If antimony vapor is allowed to condense in a cooled gas aggregation cluster source, solely cluster species belonging to the series Sb_{4n} (with $n = 1, 2, 3, \dots \sim 160$) are observed.² It has been proposed that these clusters consist of a closest packing of Sb₄ units. Structure models calculated using quantum chemical ab initio methods also indicate tetrameric subunits in the Sb_{4n} series clusters. 10,11 The binding energy of Sb₄ units in Sb_{4n} clusters (n = 2-5) has been determined to be 1.3 eV.³ This value is considerably less than the energy necessary to evaporate an Sb₄ cluster from a solid antimony surface which amounts to 2.15 eV.27,33 A solid state modification of antimony consisting solely of Sb₄ clusters, analogous to the structure of white phosphorus (P_{4n}) or yellow arsenic (As_{4n}) , has not been observed as bulk material⁶ but might exist in thin films of antimony.³ Further indication for the special geometric and electronic properties of the Sb_{4n} clusters (with n > 1) is also given by their inner shell photoionization spectra which are in striking difference to those of clusters not belonging to this series.³⁵

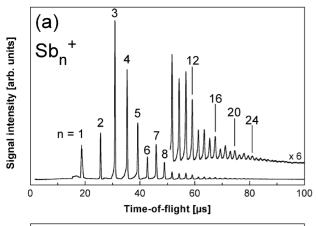
The intensity distribution in a molecular beam of charged antimony clusters turns out to be very different from the neutral cluster distributions just described. The cluster cation distributions show intensity maxima for Sb₃⁺, Sb₅⁺ Sb₇^{+,36,37} To explain these observations Wade's rules have been applied to these free semi-metal clusters. ^{38,39} According to Wade, a close connection exists between the number of valence electrons and the geometrical structure of clusters or molecules with electron deficiency. The Wade rules predict stability maxima for clusters with 2n+2 (closo-cluster), 2n+4(nido-cluster), and 2n+6 (arachno-cluster) valence electrons, n being the number of constituing atoms. They have been applied with great success to explain the structures of boranes. Using an extended approach, the so-called polyhedral skeletal electron pair theory (PSEPT), 40,41 they can also be applied to, e.g., transition metal clusters. 42 The electron configuration of antimony is Kr 4d¹⁰5s²5p³. Hence, Sb₃⁺ can be interpreted as a particular stable close-Wade-cluster, considering only the p-electrons. $\mathrm{Sb_5}^+$ and $\mathrm{Sb_7}^+$ are also stable compounds with nido- and arachno-structures, respectively. ³⁷ It should be noted that Sb₄ has a particular high stability in the framework of the PSEPT, too. A mass spectrum of positively charged antimony cluster ions generated with our discharge cluster ion source is shown in Fig. 3(a). The abundance distribution shows intensity maxima for Sb₃⁺, Sb₄⁺, Sb₅⁺, and Sb₇⁺, in accordance with the above discussion. In addition, an intensity decrease after clusters with a multiple of four atoms is observed, too.

As bismuth is the next heavier homologous element to antimony, clusters of bismuth have the same valence electron structure as the antimony clusters (s²p³). It can therefore be expected that cluster cations with three, five, and seven atoms also show enhanced stability according to PSEPT, which is indeed reflected by the intensity distribution in the mass spectrum (Fig. 3(b)).

The gas phase above liquid bismuth consists mainly of Bi atoms and Bi2 molecules with only trace amounts of Bi3 and Bi_4 present. 27,43,44 In contrast to antimony, there is no indication of the particular stability of the tetrameric bismuth cluster. The total binding energies of the dimeric and tetrameric antimony and bismuth clusters are compared in Table 1. A 4n sequence in cluster mass spectra, comparable to the Sb_{4n} series, has not been observed for bismuth clusters. Cluster distributions generated with a gas aggregation source contain all Bi_n clusters with $n \le 280$ atoms. ^{2-4,45}

B. Surface induced dissociation of antimony and bismuth cluster ions

Fig. 4(a) shows the fragment ion mass spectra of Sb₈⁺ after collision with different target surfaces in the collision energy



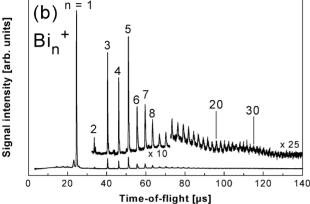


Fig. 3 Mass spectra of the unscattered beam of (a) antimony and (b) bismuth clusters. Note that besides the enhanced peak intensities for the Wade-cluster cations with 3, 5 and 7 atoms, there is a marked abundance decrease after each Sb_n^+ cluster with a multiple of four atoms $(Sb_4^+, Sb_8^+, Sb_{12}^+,...)$ which is not observed in the Bi_n^+ cluster distribution

range up to 150 eV. As can be seen from these spectra, the major fragment, Sb₄⁺, is the same for all three surfaces. In Fig. 4(b) the SID mass spectra of Bi₅⁺ are displayed. The fragment ion distributions are again similar for the two investigated surfaces up to a collision energy of 50 eV. Bi₃⁺ is the most abundant fragment ion. The result that the SID fragment ion pattern of a cluster ion is in general independent of the particular target (Au, HOPG, Si), at hyperthermal collision energies, could be confirmed for all antimony and bismuth clusters investigated. It implies that the decomposition mechanism is similar even for different surfaces.

The mechanism proposed in the literature $^{46-49}$ for the decomposition of a molecule or cluster X_n^+ due to the low energy collision with a solid surface is the activation of the ion (*) by vibrational excitation according to the general scheme:

$$X_n^+ \xrightarrow{\text{collision}} X_n^{+*} \xrightarrow{-X_m} X_{n-m}^+$$
 (1)

The interaction time of the ions with the target surface during the collision is on the order of 10^{-14} s, whereas the low energy dissociation reactions of polyatomic molecules or clusters proceed on a much longer timescale of $> 10^{-9}$ s.⁴⁸ Hence,

Table 1 Total binding energies $E_{\rm B}$ of the dimeric and tetrameric antimony and bismuth clusters

n	$E_{\rm B}({\rm Sb}_n) \ [{\rm eV}]^{31}$	$E_{\rm B}({\rm Bi}_n)~{\rm [eV]}^{65}$
2	3.1	2.06
4	8.94	6.03

it can be assumed that the decomposition of an activated ion takes place some time after the collision. ⁵⁰ By comparision with gas phase fragmentation data, we will show below that in the case of antimony and bismuth cluster cations scheme (1) corresponds to the lowest energy unimolecular dissociation reactions.

In the case of $\mathrm{Bi_5}^+$ colliding with the graphite target (Fig. 4(b)) additional smaller fragments appear above 75 eV collision energy. This indicates the onset of a new decomposition mechanism which is connected with the surface ionization of neutral fragments at the graphite substrate. This mechanism has been observed before at higher collision energies for Sb_n^+ clusters. The has been observed for C_{60} cluster collisions with graphite targets, too, the will not be discussed in this paper.

Although the general fragment ion distributions for a colliding cluster ion as depicted in Fig. 4 do not change for the different surfaces employed, the intensity of the fragment signals, e.g. Sb₄⁺ in Fig. 4(a), relative to the intensity of the incident mother ion signal (as reflected by the signal at 0 eV collision energy) varies considerably for different target surfaces. In particular, collisions with the silicon surface lead to clearly enhanced fragment ion signal intensities. For the graphite surface scattered ion yields up to at most 30% of the colliding mother ion intensity have been measured, depending on the size and the energy of the colliding cluster (see section D). The integrated fragment ion signal scattered from a gold surface was found to be comparable to or slightly less than the graphite results. In contrast, a scattered ion yield of up to 90% was observed for the oxidized silicon surface. The relatively high scattered ion yield for this surface can be related to its insulator type electronic properties, whereas the much lower work functions of the graphite and gold surfaces facilitate the efficient neutralization of the colliding cluster ions. Surprisingly large ion scattering efficiencies have been reported for gold surfaces covered with SAMs (self assembled organic monolayers), too. The organic surface acts as an insulating layer, comparable to the silicon oxide surface layer, which inhibits charge transfer to the colliding ion, thus enhancing the scattered ion yield.50

In the following discussion the SID results for antimony and bismuth clusters will be compared to other gas phase fragmentation data, in order to elucidate the general decomposition reaction pathway after surface collisional excitation in the case of the semi-metal clusters. The results of the SID measurements reported in this paper can most likely be compared with fragment ion distributions resulting from the collision of the corresponding cluster ions with gas targets at low collision energies (LE-CID, low energy collision induced dissociation⁵²), or with the metastable delayed fragmentation of previously excited clusters (MIKES, mass-analyzed ion kinetic energy spectrometry, ⁵² or laser induced evaporation ⁵³). In all these methods the dissociation reaction presumably proceeds on the potential energy surface of the electronic ground state after vibrational excitation.⁵² Other gas phase dissociative probes such as high energy collision induced dissociation (HE-CID⁵²) and photodissociation (PD⁵⁴) lead to different, generally less well defined excitation mechanisms with strong involvement of electronically excited states^{49,52} and are therefore not considered here.

In Fig. 5 the measured SID fragment ion distributions for Sb_n^+ (n=3–12) and Bi_n^+ (n=3–8) and the graphite target are displayed together with the available LE-CID, MIKES, and laser evaporation data from the literature. Table 2 shows possible fragmentation reactions of the antimony clusters with up to 8 atoms. The known dissociation energies E_D of Sb_n^+ clusters, which have been determined by electron impact mass spectrometry, are listed in Table 2 as well as literature values for the sums of the enthalpies of formation of the fragments, $\sum \Delta_f H$. The possible fragmentation reactions

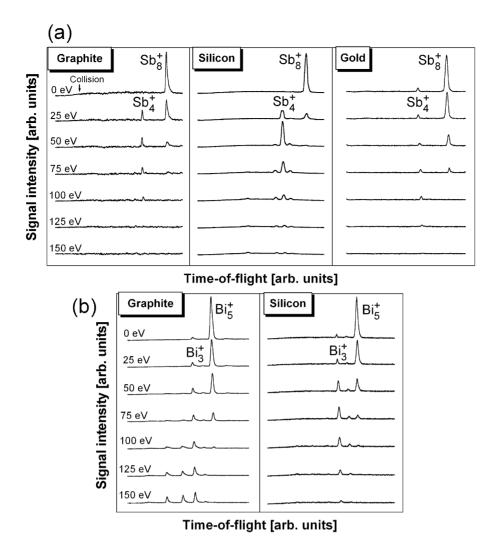


Fig. 4 Fragment ion distributions for (a) Sb₈⁺ and (b) Bi₅⁺ scattered from various surfaces at collision energies up to 150 eV. The mother ion signal at the low collision energies results from back reflected clusters, which do not reach the surface, because of the width in kinetic energy of the incident cluster beam. Note that, although the most abundant fragments (Sb₄⁺ in (a) and Bi₃⁺ in (b)) are identical for different target surfaces, the intensities of the fragment ion signals relative to the mother ion signal intensity reflected at 0 eV vary considerably for the different surfaces. Additional peaks of smaller fragments (Bi^+, Bi_2^+) appearing in (b) at higher collision energies indicate the onset of a new decomposition mechanism, see text.

for the bismuth clusters are analogous, however quantitative data for Bi_n⁺ cluster dissociation reactions are not available. In the following each cluster size will be discussed in turn.

In the case of surface induced disscociation of Sb₃⁺ the fragment ion Sb₂⁺ is generated (Fig. 5(a), left graph). The reaction leading to the observed fragment ion is highlighted in Table 2 by bold letters. The formation of Sb⁺ and two Sb atoms is energetically unfavorable (see Table 2). The observation of $Sb_2^+ + Sb$ instead of $Sb^+ + Sb_2$ can be explained by the difference in the ionization potentials (IP) of Sb_2 and Sb: $IP(Sb_2) = 8.5 \text{ eV} < IP(Sb) = 8.64 \text{ eV}.^{31,56}$ The formation of Sb₂⁺ via the lowest energy unimolecular reaction channel is in accordance with all other fragmentation measurements reported in the literature (Fig. 5(a), right graph). For the surface induced dissociation of $\mathrm{Bi_3}^+$ both, Bi^+ and $\mathrm{Bi_2}^+$ are detected (Fig 5(b), left graph). Besides the unknown stability of the charged clusters, this might be due to different ionization potentials of Bi₂ and Bi compared to Sb₂ and Sb: $IP(Bi_2) = 7.4$ $eV > IP(Bi) = 7.29 \text{ eV.}^{3-5}$ The LE-CID of Bi_3^+ results in the fragment Bi⁺ (Fig. 5(b), right graph).

For the Sb₄⁺ cluster dissociation, the formation of Sb₃⁺ was found to be the predominant dissociation pathway (cf. Fig. 5(a)), which is again in accordance with the lowest energy dissociation channel (Table 2). Sb₃⁺ fragments were also the exclusive products observed in the unimolecular gas phase dissociation of Sb₄⁺ in the MIKES and LE-CID experiments. The same applies to Bi₄⁺, except that the smaller fragments (Bi₂⁺ and Bi⁺) appear to a larger extent than in the case of Sb₄⁺ which can be ascribed to the smaller total binding energy of the bismuth clusters as seen from Table 1.

Dissociation energies from electron impact mass spectrometry are not available for clusters with more than four atoms. In the case of $\mathrm{Sb_5}^+$, $\sum \Delta_\mathrm{f} H$ values have been determined for the dissociation reactions listed in Table 2. The SID result agrees with the previous investigations as shown in Fig. 5(a). All measurements point consistently toward the lowest energy unimolecular dissociation channel as the most prominent reaction path for the surface induced dissociation of Sb₅⁺. This is the same again for Bi₅⁺.

Also, for Sb₆⁺ the SID and laser evaporation data agree with the lowest energy unimolecular dissociation reaction according to the thermochemical data in Table 2. SID of Sb₆⁺, as well as of Sb₅⁺, shows the loss of neutral antimony dimers as the preferred dissociation channel (dashed line in Fig. 5(a)). The observed major SID fragment ion of Bi₆⁺ is similar to Sb₆⁺, the tetrameric cluster (Bi₄⁺). However, LE-CID and MIKES result in Bi₅⁺ as lowest energy dissociation fragment ion of Bi₆⁺. The Bi₅⁺ fragment is also detected in

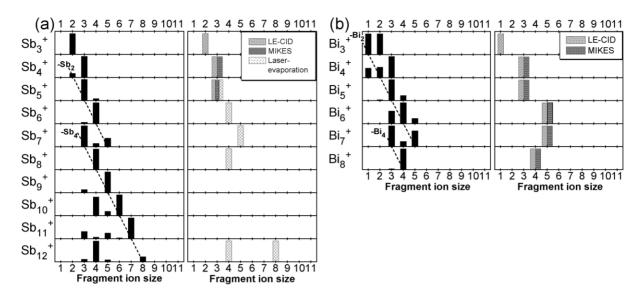


Fig. 5 SID fragment ion distributions of all investigated cluster ions at a mean collision energy of 75 eV for the antimony clusters (a) and 25 eV for the bismuth clusters (b). Target surface: graphite. The dashed lines indicate the fragment ions which are generated by the loss of neutral dimers or tetramers, respectively. The fragment ion distributions are displayed as column graphs. The height of each column represents the integral of the respective fragment ion signal. Each fragment ion mass spectrum is normalized to the intensity of the most abundant fragment. This representation enables a convenient comparison of our results with fragment ion distributions obtained with other methods, which have been reported in the literature as numerical values, and which are displayed on the right hand side of (a) and (b), respectively. LE-CID: low energy collision with argon gas. MIKES: mass analyzed ion kinetic energy spectroscopy. Laser-evaporation: unimolecular dissociation after laser excitation. Sa

our SID experiment, but with lower intensity. This might be due to the particularly weak binding energy of Bi₆⁺ compared to the amount of energy transferred to the cluster at the collision energy given in Fig. 5(b).

From Fig. 5(a) it can be seen that for Sb_7^+ the most abundant fragment ion results from a loss of four neutral antimony atoms which points toward reaction (2.1).

$$Sb_7^+ \xrightarrow{\quad Coll. \quad} Sb_7^{+*} \xrightarrow{\quad \ } Sb_3^{\ +} + Sb_4 \qquad (2.1)$$

$$\longrightarrow Sb_5^+ + Sb_2 \qquad (2.2)$$

The unimolecular dissociation of metastable $\mathrm{Sb_7}^+$ clusters after laser excitation⁵³ (Fig. 5(a), right graph) implicates that the loss of $\mathrm{Sb_2}$, as in the case of $\mathrm{Sb_5}^+$ and $\mathrm{Sb_6}^+$, is in fact the lowest energy dissociation channel (reaction (2.2)). Apparently a transition is taking place at this cluster size: from the loss of neutral dimers to the loss of stable neutral tetramers. Such a transition has been suggested from the laser evaporation experiment, too.⁵³ For clusters with seven atoms no data about dissociation energies or enthalpies of formation are available.

Table 2 Energies for the decomposition of Sb_n^+ clusters

$X_n^+ \xrightarrow{\text{collision}}$	X_{n-m}^+	X_m	$E_{\rm D}[{\rm eV}]^{3,31}$	$\sum \Delta_{\rm f} H \left[{\rm eV} \right]^{55}$
Sb ₃ ⁺	${\operatorname{Sb}_2}^+$	Sb	4.2 ± 0.4	
	Sb ⁺	Sb_2		
	Sb^{+}	2Sb	7.3 ± 0.4	
${\operatorname{Sb}_4}^+$	${\operatorname{Sb}_3}^+$	Sb	2.70 ± 0.16	2.21
	$\mathrm{Sb_2}^+$	Sb_2	3.80 ± 0.12	3.43
	Sb ⁺	3 Sb	9.92 ± 0.12	
Sb ₅ ⁺	$\mathrm{Sb_3}^+$	Sb_2		9.87
	${\operatorname{Sb_4}}^+$	Sb		10.08
	${\operatorname{Sb}_2}^+$	Sb_3		11.14
	Sb^{+}	Sb_4		11.60
Sb ₆ ⁺	${\operatorname{Sb}_4}^+$	Sb_2	9.87	
	$\mathrm{Sb_3}^+$	Sb_3		10.23
	$\mathrm{Sb_2}^+$	Sb_4		11.07
${\rm Sb_8}^+$	$\mathrm{Sb_4}^+$	Sb_4	1.3	

 ${\rm Sb_4}^+$ is the only fragment of ${\rm Sb_8}^+$ at low collision energy, which is in accordance with the unimolecular decomposition of excited, metastable ${\rm Sb_8}^+$ clusters.⁵³ Therefore it can be assumed that the unimolecular dissociation reaction (3) leads to the observed fragment ion.

$$Sb_8^+ \xrightarrow{Coll.} Sb_4^+ + Sb_4$$
 (3)

The dissociation energy of this reaction, and of the endothermal loss of $\mathrm{Sb_4}$ from $\mathrm{Sb_{12}}^+$, $\mathrm{Sb_{16}}^+$, and $\mathrm{Sb_{20}}^+$ as well, has been measured by electron impact ionization to be 1.3 $\pm 0.25 \ \mathrm{eV}^3$ (Table 2) Photodissociation experiments by Bréchignac and coworkers⁵³ support this value. They find an average dissociation energy for the loss of $\mathrm{Sb_4}$ from $\mathrm{Sb_{4n}}^+$ (n=2 to 20) of 1.35 eV.

The SID fragmentation patterns of the investigated Sb_n⁺ and $\operatorname{Bi}_{n}^{+}$ (up to eight atoms) are very similar (Fig. 5). Also, the decomposition of Bi₇⁺ and Bi₈⁺ is characterized by the preferred loss of neutral tetrameric (and dimeric) cluster units. This observation suggests that these cluster units, in particular the tetramer, might be major structural building blocks of the clusters of both semi-metals, as proposed from ab initio claculations for the antimony clusters. 11 Considering that the corresponding antimony and bismuth clusters are isoelectronic, it can be assumed that also in the case of the investigated bismuth cluster ions, the observed fragments are produced via the lowest energy unimolecular dissociation reactions. The larger abundance of smaller fragment ion signals observed already at lower collision energies in the SID spectra of bismuth clusters is explained by their generally lower binding energies than the corresponding antimony clusters (Table 1).

The fragmentation behavior of the cluster ions $\mathrm{Sb_9}^+$, $\mathrm{Sb_{10}}^+$, and $\mathrm{Sb_{11}}^+$ has not been investigated previously. The decay of metastable $\mathrm{Sb_{12}}^+$ clusters after laser excitation has been shown to proceed as unimolecular decomposition reaction *via* the loss of $\mathrm{Sb_4}$ units as displayed in Fig. 5(a). This is also the primary fragmentation reaction observed in our SID investigation for $\mathrm{Sb_{12}}^+$ and for the other cluster ions with nine to eleven atoms (Fig. 5(a)). Further major fragment ions of the clusters Sb_n^+ (n=9–12) can be explained by the successive loss of neutral $\mathrm{Sb_4}$ and $\mathrm{Sb_2}$ units according to unimolecular fragmentation steps. This similar dissociation behavior for clusters belonging

to the series with a multiple of four atoms $(Sb_8^+$ and $Sb_{12}^+)$ and those not belonging to this series (Sb₉⁺, Sb₁₀⁺ and Sb₁₁⁺) implies that there is no principal structural difference either between these clusters cations and that the tetrameric unit is an important structural unit. Further decomposition into smaller fragments is reduced, if one of the stable Wadefragment ions Sb₅⁺ or Sb₇⁺ is formed.

If the vibrational energy, which is transferred to the fragment ion in the course of the collision process, is larger than its dissociation energy, and if competing dissociation pathways that require a comparable amount of energy are negligible, then a sequential decomposition takes place:

$$X_n^+ \xrightarrow{\text{collision}} X_n^{+*} \xrightarrow{-X_m} X_{n-m}^{+*} \xrightarrow{-X_u} X_{n-m-u}^{+*} \xrightarrow{} \dots$$
(4)

In Fig. 6 the fragment ion distributions of Sb₁₀⁺, Sb₁₁⁺ and Sb₁₂⁺ are displayed at three different collision energies. From these examples it can be seen that the intensities of the smaller fragments increase continuously with the collision energy which is characteristic for a sequential fragmentation reaction. In combination with the observed unimolecular fragmentation behavior, this observation will be used in the following section to determine energy conversion efficiencies during cluster-surface collision.

Kinetic to internal cluster energy conversion upon collision

For a detailed understanding of the cluster surface interaction it is important to know the amount of the kinetic energy which is transferred into internal energy of the cluster in the course of the inelastic collision. The redistribution of the collision energy in surface phonon excitation, in thermal excitation of the colliding cluster as well as in the kinetic energy of the scattered cluster fragments cannot be observed directly in our experiment. However, if the decomposition mechanism proceeds via sequential dissociation reactions with similar entropy requirements and known reaction energies, it is possible to estimate the distribution of internal energies P(E) in a population of colliding cluster ions from the intensity patterns in the fragment ion mass spectra by applying simple thermochemical considerations.5

In the preceding discussion it could be shown that in the investigated range of of hyperthermal collision energies, indeed a sequential fragmentation of the antimony clusters Sb_n⁺ $(n \ge 7)$ takes place with the preferred loss of stable neutral Sb₄ and Sb₂ units (Fig. 4). The reaction energies $E_{D,i}$ for all the single unimolecular dissociation steps, however, are only known for Sb₈⁺ and Sb₁₂⁺. The following reaction scheme (5) shows the successive fragmentation steps for Sb₁₂⁺ and

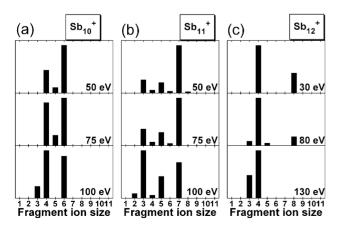


Fig. 6 Fragment ion distributions of (a) Sb_{10}^+ , (b) Sb_{11}^+ , and (c) Sb₁₂⁺ measured at three different collision energies. Target surface: graphite.

Table 3 Appearance energies $E_{a,i}$ of the fragments F_i^+ and average internal energies E_i of the mother ion Sb_{12}^+ according to the sequential dissociation reaction (5)

i	${F_i}^+$	$E_{a,i}$ [eV]	E_i [eV]
0	${\operatorname{Sb}_{12}}^+$	0	0.65
1	${\operatorname{Sb}_{12}}^+ \ {\operatorname{Sb}_8}^+$	1.3	1.95
2	$\operatorname{Sb_4}^+$	2.6	3.95
3	Sb ₃ ⁺	5.3	7.4
4	Sb_2^+	9.5	11.08
5	${\operatorname{Sb}_3}^+ \ {\operatorname{Sb}_2}^+ \ {\operatorname{Sb}^+} \ $	12.66	> 12.66

the corresponding dissociation energies (data are taken from references 31 and 3):

$$Sb_{12}^{+} \xrightarrow{-Sb_{4}} Sb_{8}^{+} \xrightarrow{-Sb_{4}} Sb_{4}^{+} \xrightarrow{-Sb} Sb_{4}^{+} \xrightarrow{-Sb} Sb_{3}^{+}$$

$$\xrightarrow{-Sb} Sb_{2}^{+} \xrightarrow{-Sb} Sb_{2}^{+} \xrightarrow{-Sb} Sb^{+} (5)$$

The method used here for the calculation of the internal energy distribution has been proposed by Cooks and coworkers. 57,58 Single values for the distribution of internal energies $P_i(E_i)$ are deduced from the intensity of the fragment ions $[F_i^+]$ weighted by the width of the energy interval $[E_{a,(i+1)} - E_{a,i}]$ in which the fragment F_i^+ is observed:

$$P_i(E_i) = \frac{[F_1^+]}{[E_{a,(i+1)} - E_{a,i}]}$$
 (6)

 $E_{a,i}$ is the energy at which the fragment F_i^+ starts to appear, i.e. the minimum internal energy which the mother ion F_0^+ needs in order to form such a fragment. E_i is the average internal energy that a mother ion F_0^+ possessed which formed a fragment F_i^+ . In Table 3 these values are listed for the fragmentation of Sb_{12}^{+} according to the reaction sequence (5).

Fig. 6(c) shows three fragment ion mass spectra of Sb₁₂⁺ obtained at collision energies of 30, 80 and 130 eV, respectively. The target surface is graphite. The distribution of internal energies $P_i(E_i)$ obtained from the fragment ion intensities in these mass spectra in combination with the energy data in Table 3 are depicted in Fig. 7. Gaussian curves have been fitted to the data points, which reflect the distribution of internal energies at the different collision energies well as detailed, e.g., in reference. 49 Characteristic for the SID compared to the other methods are the well defined impact parameters,

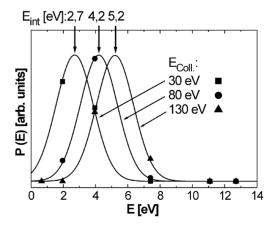


Fig. 7 Internal energy distributions P(E) of Sb_{12}^+ clusters at three collision energies calculated from the intensity distributions in Fig. 6 as explained in the text. Gaussian functions have been fitted to the data points at each collision energy which represent the estimated internal energy distribution. The average internal energies $E_{\rm int}$ are obtained from the maxima of the distributions.

the high energy conversion efficiency, and the relatively narrow distribution of internal energies that are deposited in the ion upon collision. $^{48-50}$ The maxima of the distribution curves give the average internal energy $E_{\rm int}$, which is transferred to the cluster at the corresponding impact energy. Eint is plotted in Fig. 8 as a function of collision energy for the impact of Sb₁₂⁺ clusters onto graphite as well as onto a silicon surface. The energy transfer efficiency is largest (about 10%) at low collision energies and decreases almost linearly to about 4% at 150 eV collision energy. It is interesting to note that the amount of internal energy transferred to the cluster upon collision for the two different surfaces is comparable within about 1 eV although the target atomic mass and the elastic properties of the two surfaces are clearly different. It has been demonstrated theoretically quite recently that the energy transfer efficiency is, e.g., a strong function of the surface stiffness.⁵⁹ Extended investigations of these issues with improved experimental energy resolution are in progress.60

Molecular dynamics simulations have shown the extreme thermodynamical conditions which are occurring for a very short time (on a femto- or picosecond time scale) during the cluster surface collision. $^{61-64}$ To relate the calculated internal energies to thermodynamical temperature values, we determine the vibrational temperatures T at the corresponding collision energies using the equipartitioning theorem

$$T = \frac{E_{\text{int}}}{(3n-6)k_{\text{B}}},\tag{7}$$

where $k_{\rm B}$ is the Boltzmann constant and (3n-6) is the number of vibrational degrees of freedom in an n atom cluster. The thus obtained temperature scale is also included in Fig. 8. According to this estimation, vibrational temperatures of several thousand Kelvin can be achieved during the collision. Comparable temperatures have also been reported from MD-simulations of collisions of rare gas^{61–63} and metal⁶⁴ clusters with solid surfaces. In a 200 eV collision of a Cu₁₄₇ cluster with a Cu(111) surface, *e.g.*, temperatures up to 2100 K are present for several picoseconds.⁶⁴

D. Scattered ion yield

The integral scattered ion yield in percent at a certain collision energy is obtained by integrating all fragment ion signals and normalizing this value to the total intensity of the colliding mother ion. The scattered ion yield is determined by the electronic interaction of the cluster ions with the surface, *i.e.* the neutralization process. The dependence of the integral scattered ion yield on the size of the colliding clusters thus gives

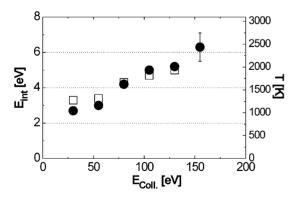


Fig. 8 Average internal energies $E_{\rm int}$ acquired by an ${\rm Sb_{12}}^+$ cluster during collision with a graphite (filled circles) and a silicon surface (open squares) displayed as a function of collision energy, *i.e.* kinetic energy of the incident clusters. A typical error bar is shown. The right ordinate gives the vibrational temperatures at the corresponding internal energies calculated according to eqn. (7).

information about differences in the electronic structure of clusters with different number of atoms (for the same surface). In Fig. 9(a) and (b) the integral scattered ion yield of antimony clusters at a collision energy of 75 eV is displayed as a function of the size of the colliding mother ion. The results for the collision with a graphite and a silicon surface are shown. The overall trend for the anitmony clusters is an increase in the scattered ion yield with increasing cluster size. However, this increase is not continuous. For both substrates and n > 5, larger scattered ion yields are measured for the scattering of clusters with an odd number of atoms in comparison to the adjacent cluster sizes with an even number of atoms.

Since the neutralization probability is a function of the energy difference between the ionization potential of the colliding cluster ion and the surface work function, 47,50 the observed higher average ion yield of the odd size clusters suggests that these clusters have in general lower ionization potentials than the even sized clusters. Up to now, however, there are no experimental or theoretical data available on the ionization potentials of Sb_n^+ clusters with an odd number of atoms (for $n \geq 5$). As discussed previously, the higher scattered ion yield for the silicon target can be related to its comparatively high work function, resulting in a weak neutralization efficiency.

The measured scattered ion yield for the Bi_n⁺ clusters scattering from graphite is larger than for the corresponding Sb_n⁺ clusters, which correlates well with the about 1 eV lower ionization potentials of bismuth clusters compared to antimony clusters.³ The largest scattered ion yields for the graphite target, about 14% at 50 eV collision energy, have been measured for the odd size clusters Bi₅⁺ and Bi₇⁺. The size variations are, however, within the experimental error bars. Also the known ionization potentials of bismuth clusters shows no marked variation in the size range between four and eight atoms.^{3–5} Scattering bismuth clusters from the silicon target again leads to considerably enhanced scattered ion yields, as can be seen from Fig. 4(b) at, e.g., 75 eV collision energy.

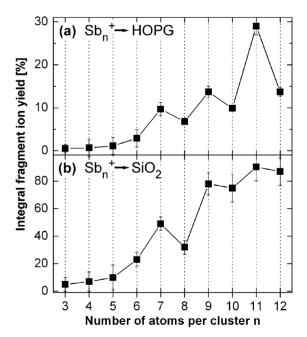


Fig. 9 Integral scattered ion yield as a function of the size of the colliding cluster for the scattering of antimony clusters from different surfaces. (a) Sb_n^+ scattered ion yield at a collision energy of 75 eV. Substrate: graphite. (b) Sb_n^+ scattered from the silicon substrate (same impact energy). The error bars take into account the slightly different energy width in the different experiments as well as a larger error in the scattered ion yield at low collision energies due to the reflected mother cluster ions.

IV. Conclusions

The fragmentation of semi-metal cluster ions of antimony and bismuth upon collision with a solid surface has been investigated. The decomposition of the cluster ions has been analyzed as a function of cluster size, collision energy, and surface type. By comparison with fragmentation data from the literature, it could be shown that in the investigated collision energy range up to 150 eV the clusters undergo a sequential unimolecular decomposition according to the lowest energy dissociation reactions. The fragment ion patterns of the investigated clusters and therefore the observed decomposition mechanism are found to be independent of the target surface. However, large changes in the overall scattered ion yield are observed for the different target surfaces employed. The highest scattered ion yield of up to 90% is detected for a high work function silicon oxide surface, whereas the scattering from a graphite and a metallic gold surface leads to considerably lower scattered ion yields. This is assigned to the difference in the electronic surface structure, in particular the surface work function. We also observe strong variations in integral scattered ion yield as a function of the cluster size for a given surface. The degree of conversion of kinetic energy to internal vibrational energy of the clusters was determined for Sb₁₂⁺ in collision with graphite and silicon surfaces. It varies between 4% at 130 eV and about 10% at 30 eV collision energy for both surfaces. The corresponding antimony and bismuth cluster ions show identical major fragment ions which points toward similar structural properties. Preferred loss of neutral tetramer and dimer units is observed. For the bismuth clusters smaller fragments are detected already at lower collision energies which reflects the lower stability of the bismuth cluster ions in comparison to antimony clusters.

Acknowledgement

The work presented here has been supported by the Deutsche Forschungsgemeinschaft, the Fonds der Chemischen Industrie, and by the Humboldt Forschungsfonds.

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